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(54) **METHOD AND APPARATUS FOR TESTING LIQUID CRYSTAL DISPLAY DEVICE**

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(57) **ABSTRACT**

A method and apparatus for testing a liquid crystal display device are provided to detect a defect location precisely and rapidly without requiring a jig. The method includes providing a substrate to inspect, wherein the substrate includes signal wirings, drive switches and capacitors formed in an effective display area of the substrate; radiating a light onto an inspection switch device and thereby supplying an inspection voltage from an inspection line to one of the drive switches through the signal wirings, so as to charge one of the capacitors; and determining if there is a defect in the effective display area of the substrate by reading the charged voltage of the capacitor.

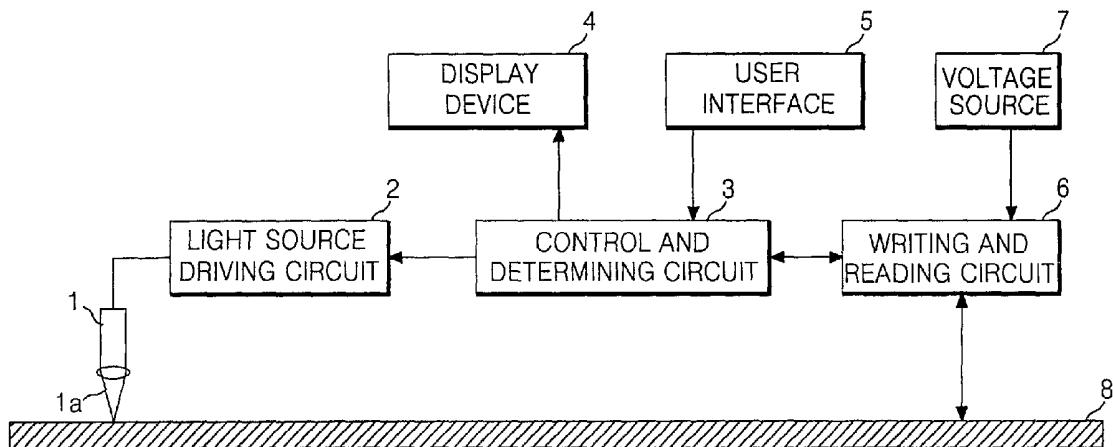


FIG. 1  
RELATED ART

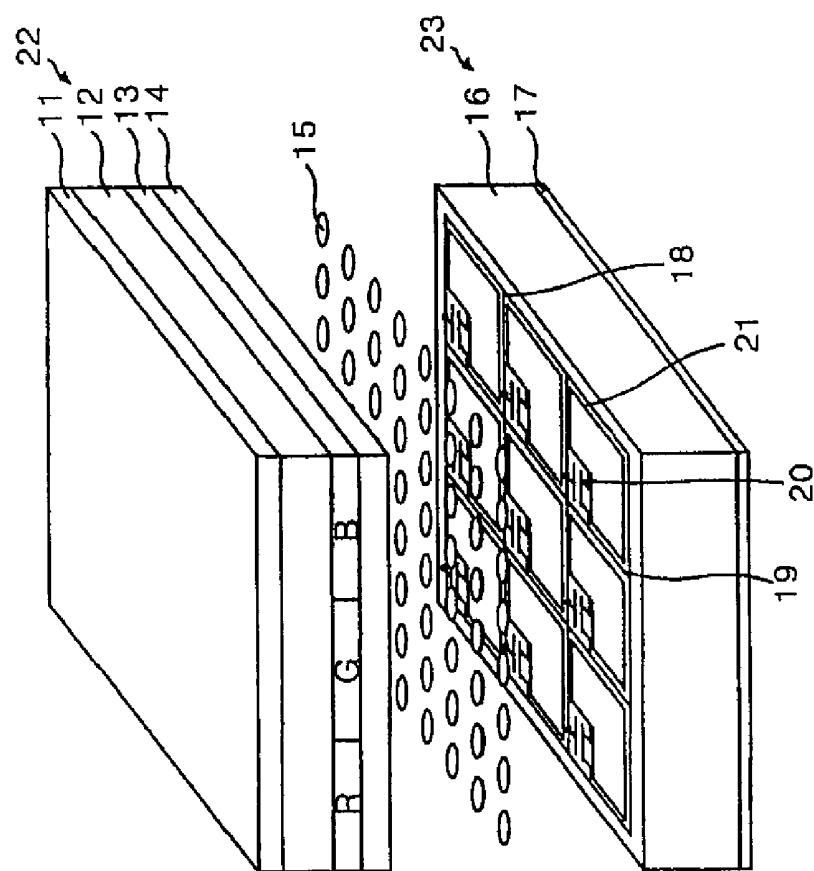


FIG. 2  
RELATED ART

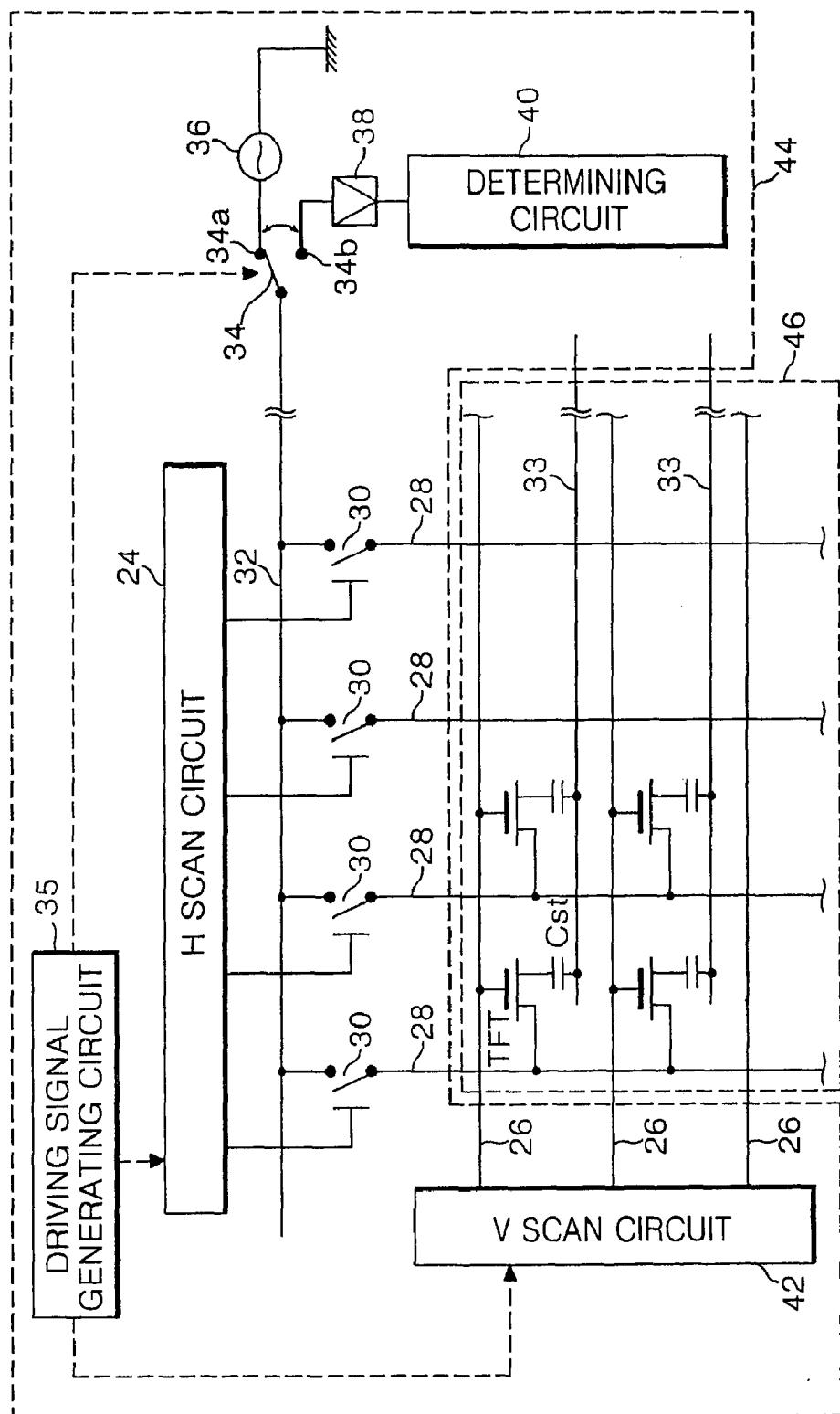


FIG. 3

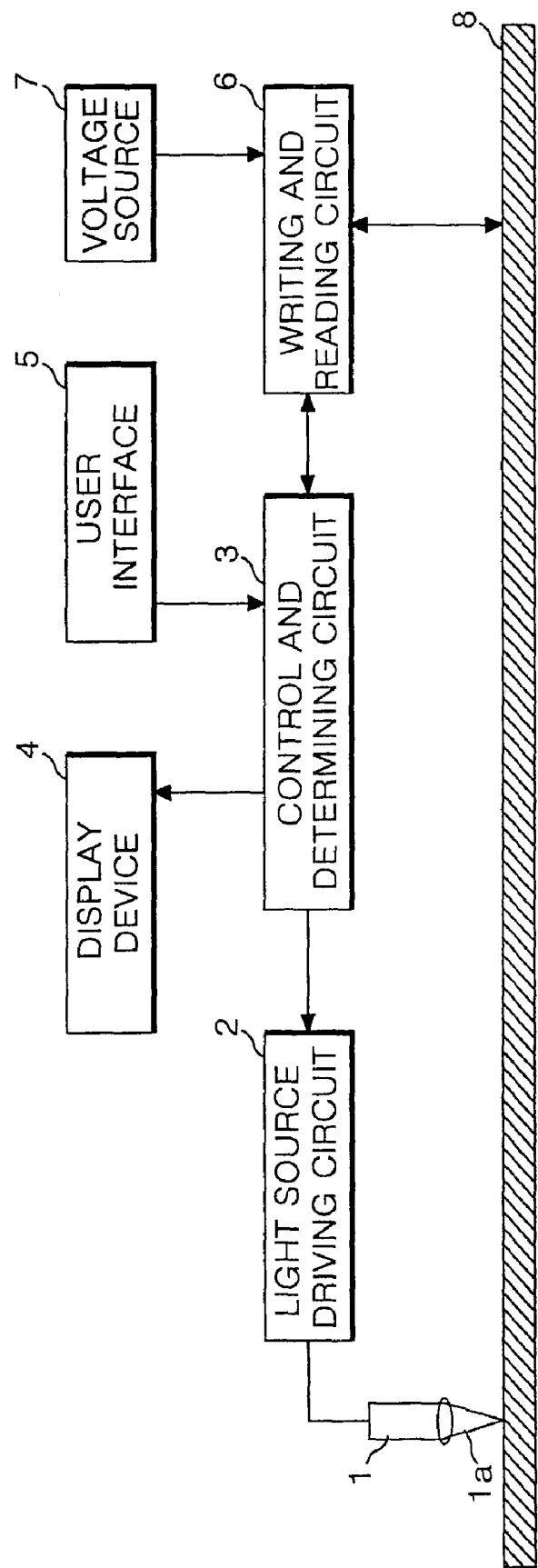


FIG. 4

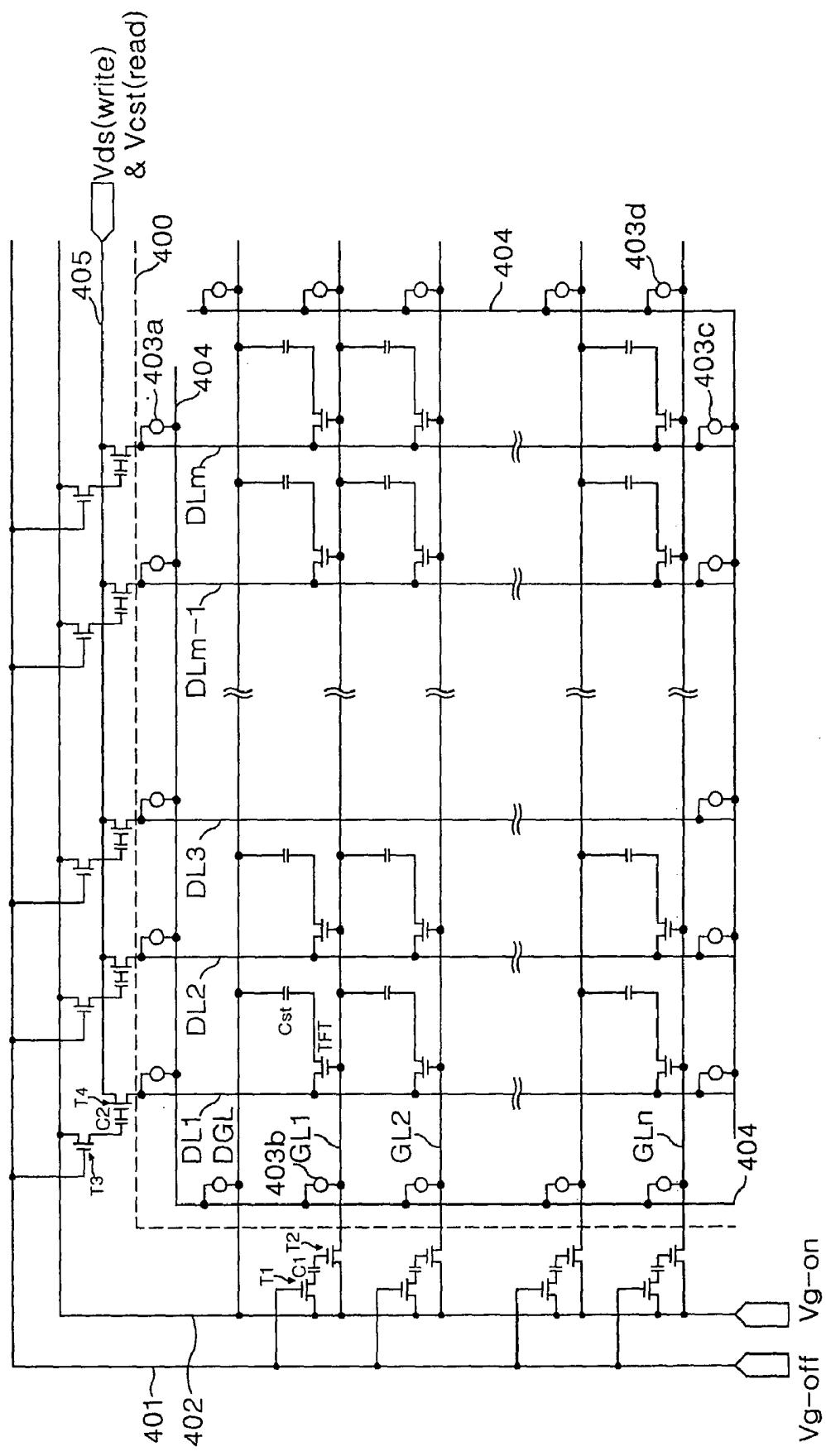


FIG. 5

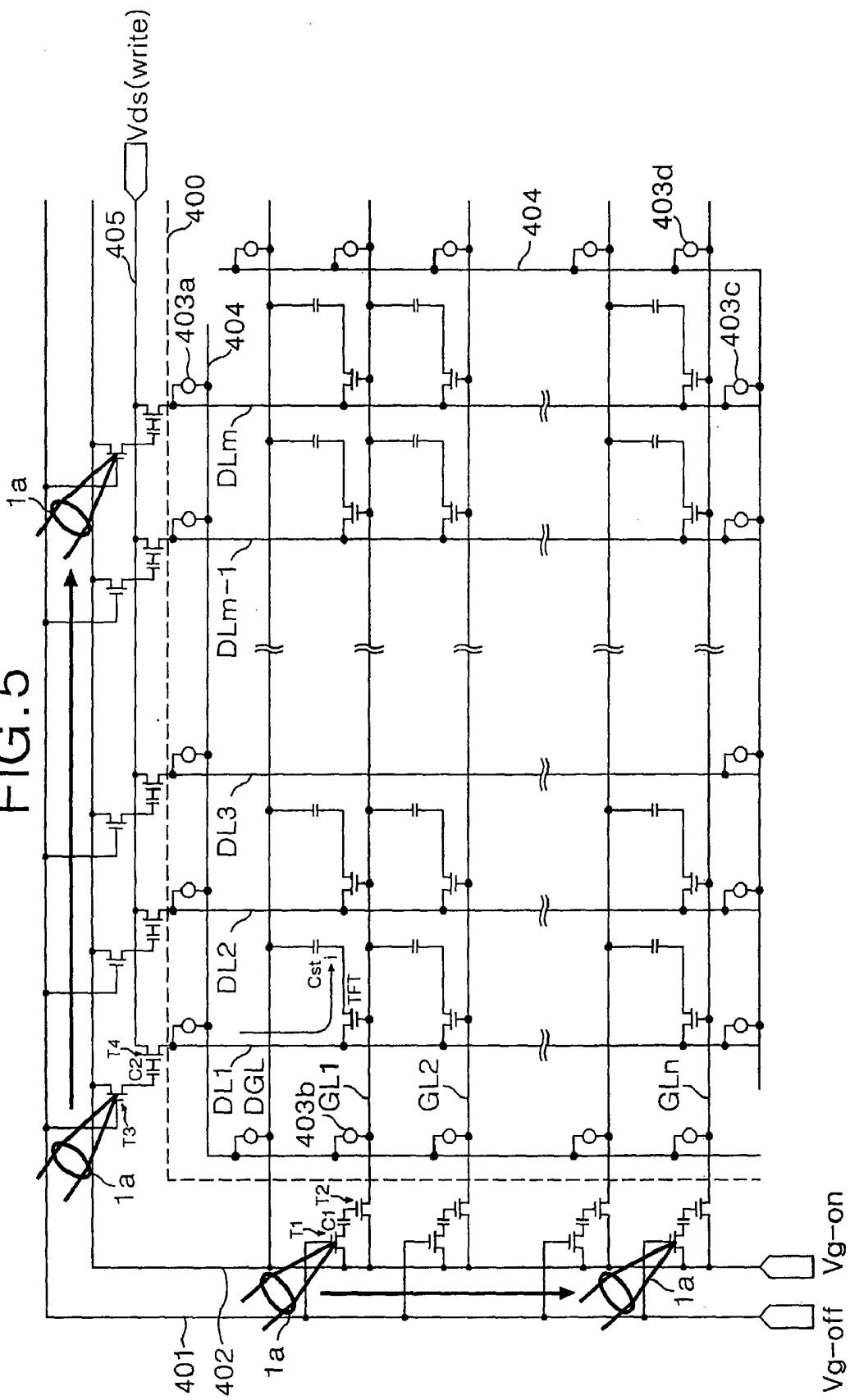


FIG. 6

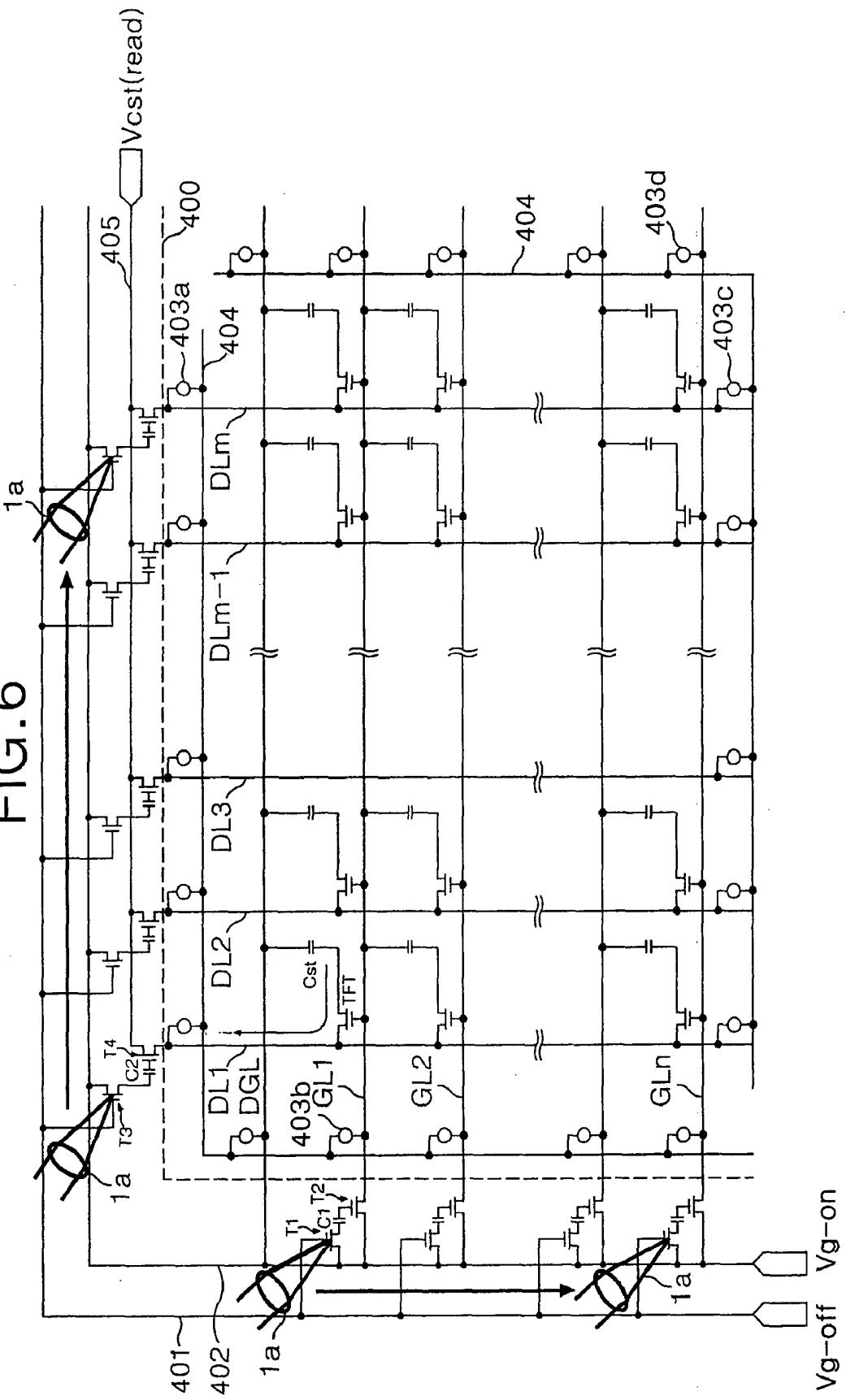


FIG. 7

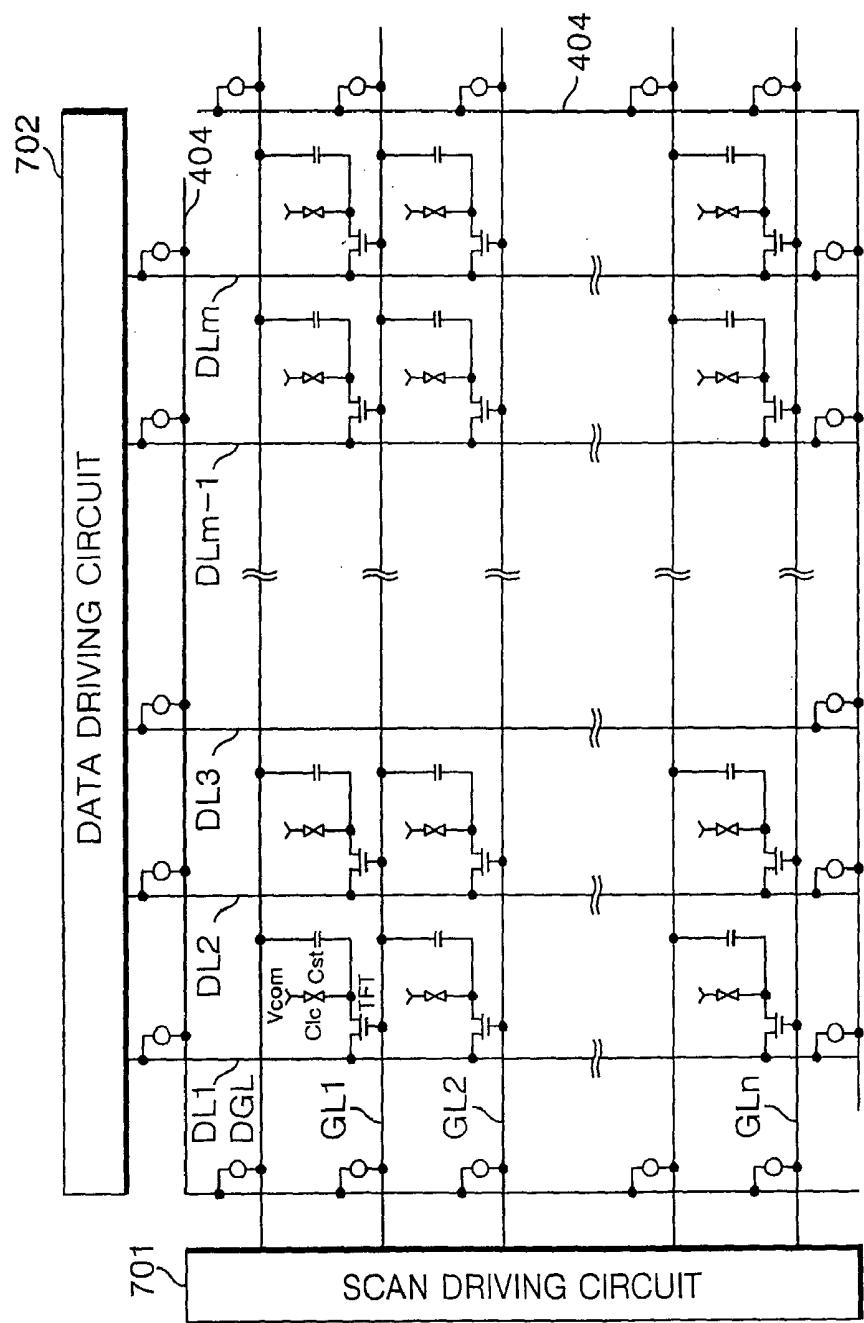
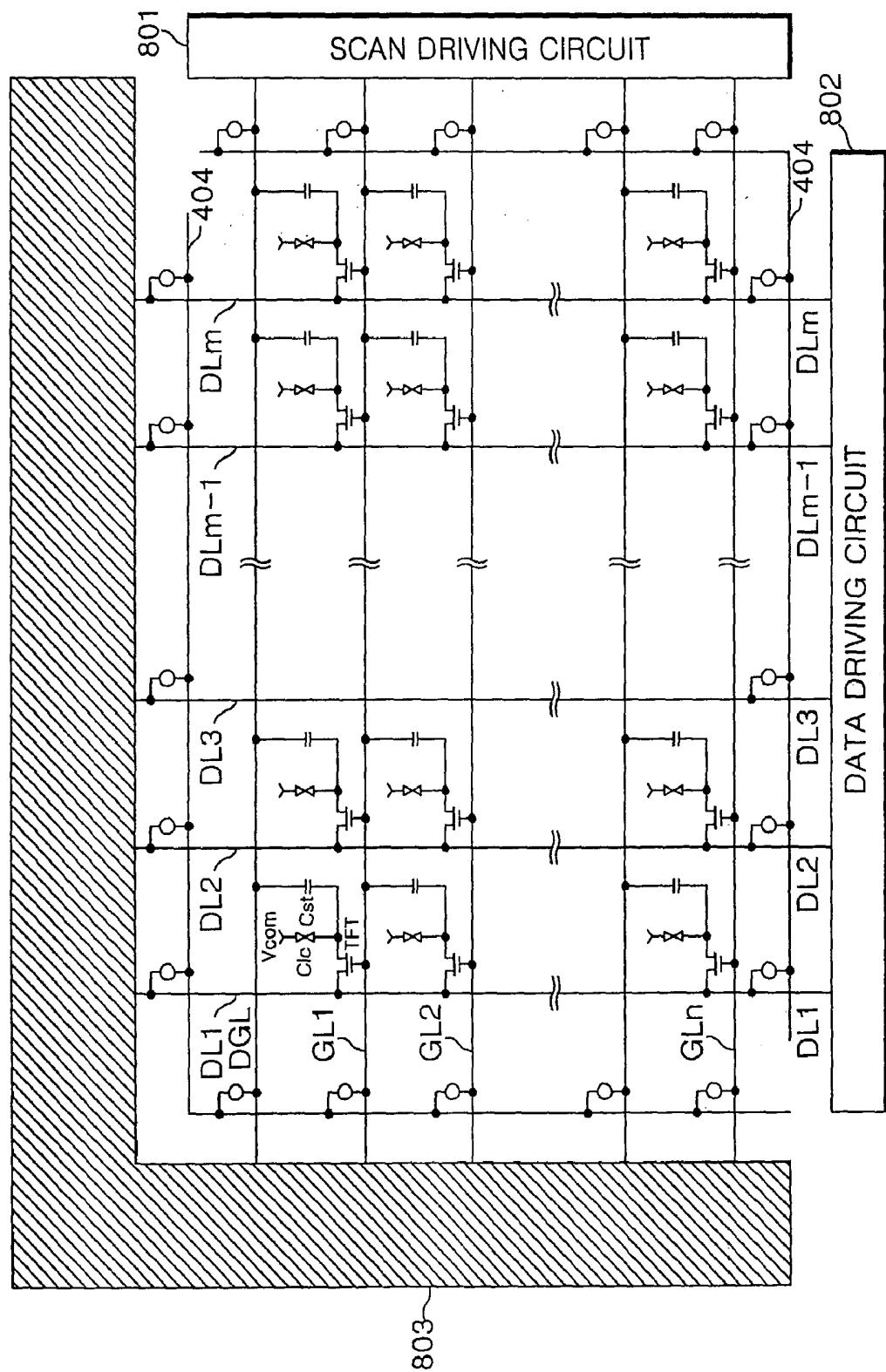


FIG. 8



## METHOD AND APPARATUS FOR TESTING LIQUID CRYSTAL DISPLAY DEVICE

[0001] The present application claims, under 35 U.S.C. § 119, the priority benefit of Korean Patent Application No. P2003-28644, filed May 6, 2003, the entire contents of which are herein fully incorporated by reference.

### BACKGROUND OF THE INVENTION

#### [0002] 1. Field of the Invention

[0003] The present invention relates in general to a liquid crystal display (LCD) device and, more particularly, to a method and apparatus for testing an LCD device to detect a defective location on the LCD device precisely and rapidly without requiring a jig.

#### [0004] 2. Description of the Related Art

[0005] Display apparatuses have become important as visual information transferring media. Among the display apparatuses, a cathode ray tube is widely used at present, but is disadvantageous in that its weight and volume are large. Therefore, various types of flat display apparatuses have been developed that are capable of overcoming the defects of the cathode ray tube. An LCD, a field emission display (FED), a plasma display panel (PDP), and an electroluminescence (EL) display are different examples of flat display apparatus. Most of these apparatuses are available in the market.

[0006] The LCD device is easily adaptive due its smallness which improves productivity. Thus, it is quickly replacing the cathode ray tubes in many applications. In particular, the LCD device of an active matrix type for driving a liquid crystal cell by using a thin film transistor (hereinafter referred to as "TFT") has an advantage in that the picture quality it provides is excellent, and its power consumption is low. Such LCDs have been rapidly developed into a large size and high definition due to the recent productivity technology and research.

[0007] As shown in FIG. 1, in the LCD of the active matrix type, a color filter substrate 22 and a TFT array substrate 23 are assembled with a liquid crystal layer 15 therebetween. The LCD shown in FIG. 1 represents a portion of a total effective display.

[0008] The color filter substrate 22 includes an upper glass substrate 12, and a color filter 13 and a common electrode 14 formed thereon. Attached on a front surface of the upper glass substrate 12 is a polarization plate 11. In the color filter 13, the color filter layers of red, green and blue colors are disposed and transmit a light of special wavelength bandwidth to display a color. A black matrix (not shown) is formed between the color filters 13 of the adjacent color.

[0009] Data lines 19 and gate lines 18 cross each other on the entire surface of a lower glass substrate 16 in the TFT array substrate 23. TFTs 20 are formed at the intersections of the gate and data lines 18 and 19. A pixel electrode 21 is formed at a cell region between each of the data lines 19 and gate lines 18 on the entire surface of the lower glass substrate 16. Each TFT 20 switches a data transfer path between the corresponding data line 19 and the corresponding pixel electrode 21 in response to a scanning signal from the corresponding gate line 18 and thus drives the corre-

sponding pixel electrode 21. A polarization plate 17 is installed on a rear surface of the TFT array substrate 23.

[0010] The liquid crystal layer 15 adjusts a transmitting quantity of an incident light via the TFT array substrate 23 in response to an electric field applied thereto. The polarization plates 11 and 17 installed on the color filter substrate 22 and the TFT array substrate 23 transmit the light polarized to one direction. When the liquid crystal layer 15 is at 90°TN mode, the polarization directions of the polarization plates 11 and 17 vertically cross each other. An alignment film (not shown) is formed on the facing surfaces of the color filter substrate 22 and the TFT array substrate 23.

[0011] A process for fabricating the LCD device of the active matrix type is divided into a substrate cleaning, a substrate patterning, an alignment forming/rubbing, a substrate assembling/liquid crystal material injecting, a mounting, an inspecting and a repairing.

[0012] Generally, impurities on the substrate surface of the LCD device are removed by a detergent in the substrate cleaning process. The substrate patterning process is divided into a patterning process of the color filter substrate and a patterning process of the TFT array substrate. The alignment film forming/rubbing process involves applying an alignment film to each of the color filter substrate and the TFT array substrate and rubbing the alignment film. The substrate assembling/liquid crystal injecting process is to assemble the color filter substrate and the TFT array substrate by using a sealant, to inject the liquid crystal and a spacer through a liquid crystal injection hole and then to seal the liquid crystal injection hole.

[0013] In the mounting process of the liquid crystal panel, a tape carrier package (hereinafter referred to as "TCP") is connected to a pad part on the substrate, wherein the TCP has integrated circuits mounted thereon such as a gate drive integrated circuit and a data drive integrated circuit. Such drive integrated circuits may be directly mounted on the substrate by using a chip on glass (hereinafter referred to as "COG") method besides a TAB (Tape Automated Bonding) using the TCP described above.

[0014] The inspecting process includes a first electrical inspection performed after forming a variety of signal wirings such as the data line and the gate line on the TFT array substrate and the pixel electrode, and a second electrical inspection and a visual inspection performed after the substrate assembly/liquid crystal injection process. Specifically, the electrical inspection of the signal wirings of the TFT array substrate and the pixel electrode of the lower substrate performed before the substrate assembling process may reduce an undesirable ratio and a waste matter and may find a defective substrate capable of repairing at an early stage.

[0015] The repairing process performs a restoration for a repairable substrate determined by the inspecting process. However, in the inspecting process, defective substrates beyond repair are discarded.

[0016] The device as shown in FIG. 2 may be used in an inspection process carried out before the substrate assembling. The inspection device shown in FIG. 2 is fully described in U.S. Pat. No. 5,377,030.

[0017] Referring to FIG. 2, the inspection device of the related art includes an inspection switch device 34 for

selectively supplying a voltage from an inspection power supply **36** to a video signal input wiring, and a voltage from a current-voltage amplifier **38** under the control of a driving signal generation unit **35**, a scanning switch device **30** for supplying the inspection voltage from the video signal input wiring **32** to the data lines **28** of a TFT array **46** of an active matrix LCD under control of an H scanning circuit **24**, a V scanning circuit **42** for driving the gate lines **26** of the TFT array **46** under control of the driving signal generation unit **35**, and a determining unit **40** for determining an electrical defect in the TFT array **46**. The data lines **28** and gate lines **26** cross each other in the TFT array **46**, and TFTs are formed at their intersections. Further, common wirings **33** and a storage capacitor Cst between the common wirings **33** and a drain electrode of the TFT are formed in the TFT array **46**.

**[0018]** The inspection of the TFT array **46** includes a sequence of loading a substrate having the TFT array **46** formed thereon to the inspection device, writing the inspection voltage to the TFT array **46** and reading a signal from the TFT array **46**.

**[0019]** After loading the substrate having the TFT array **46** to the inspection device, the writing process of the inspection voltage is performed. In the writing process of the inspection voltage, the inspection switch device **34** is connected to the first terminal **34a** and the scanning switch device **30** is turned on under control of the H scanning circuit **24**. Accordingly, the inspection voltage generated from the inspection power supply **36** is supplied to the data lines **28** of the TFT array **46** via the inspection switch device **34**, the video signal input wiring **32** and the scanning switch device **30**. At the same time, the V scanning circuit **42** supplies a test scan voltage to the gate lines **26** under control of the driving signal generation unit **35**. Then the TFTs are turned on in the selected lines of the TFT array **46**, and the inspection voltage on the data lines **28** is charged to the storage capacitors Cst via the TFTs.

**[0020]** In the reading process of the inspection voltage, the inspection switch device **34** is connected to the second terminal **34b** and the scanning switch device **30** is turned on under control of the H scanning circuit **24**. At the same time, the V scanning circuit **42** supplies the test scan voltage to the gate lines **26** under control of the driving signal generation unit **35**. Then, the TFTs are turned on in the selected lines of the TFT array and the voltage of the corresponding storage capacitor Cst is supplied to the current-voltage amplifier **38** via the TFTs, the data line **28**, the scanning switch device **30**, the video signal input wiring **32** and the inspection switch device **34**. The voltage read from the storage capacitor Cst is supplied to the determining unit **40** after being amplified by the current-voltage amplifier **38**, and the determining unit **40** determines if there is a defect in the TFT array **46** based on the voltage supplied by the current-voltage amplifier **38**.

**[0021]** However, since the substrate (having the TFT array **46**) to be inspected is not equipped with the driving circuit and the inspection device, a separate jig is needed to accommodate the driving signal generation unit **35**, the H scan circuit **24**, the V scan circuit **42**, the scanning switch device **30**, the video signal input wiring **32**, the inspection switch device **34**, the inspection power supply **36**, the current-voltage amplifier **38** and the determining unit **40**. As a result, there is a problem that the inspection device of the

related art shown in **FIG. 2** needs a high price jig. Further, if the resolution of the LCD or a model is changed, the jig needs to be changed correspondingly. On the other hand, if the TFT array **46** is inspected by a block dividing method concurrently driving a plurality of gate lines **26** and a plurality of data lines **28**, the number of input/output terminals of the jig and the circuit price of the jig may be reduced. However, there is another problem that a defect location within the block cannot be detected with precision.

## SUMMARY OF THE INVENTION

**[0022]** Accordingly, it is an object of the present invention to provide a method and apparatus for testing an LCD display device which can detect a defective location precisely and rapidly without requiring a jig.

**[0023]** It is another object of the present invention to provide a method and apparatus for testing an LCD which overcomes the limitations and problems of the related art.

**[0024]** In accordance with an aspect of the invention, a method of inspecting a liquid crystal display device using an inspection apparatus, the inspection apparatus including a light source, at least one inspection line and at least one inspection switch device connected to the inspection line, the method includes: providing a substrate, wherein the substrate includes a plurality of signal wirings, a plurality of drive switches, and a plurality of capacitors formed in an effective display area of the substrate; radiating a light generated from the light source of the inspection apparatus onto the at least one inspection switch device and thereby supplying an inspection voltage from the at least one inspection line to a corresponding one of the drive switches through the signal wirings, so as to charge a corresponding one of the capacitors; and determining if there is a defect in the effective display area of the substrate by reading the charged voltage of the corresponding one of the capacitors.

**[0025]** In accordance with an aspect of the invention, a method of inspecting a substrate device, the substrate device including signal wirings, drive switches and capacitors formed in a main area of the substrate device, and an inspection line and an inspection switch formed at an exterior of the main area, the drive switches being coupled to the capacitors, the inspection switch being coupled to the inspection line, the method includes: supplying an inspection voltage to the inspection line of the substrate device; charging one of the capacitors with the inspection voltage through the signal wirings; and determining if there is a defect in the substrate device by reading the charged voltage of the capacitor.

**[0026]** In accordance with an aspect of the invention, a method of inspecting a display part of a liquid crystal display device, the method includes: providing an inspection apparatus as a removable portion of the liquid crystal display device; inspecting the display part of the liquid crystal display device using the inspection apparatus; removing the inspection apparatus from the liquid crystal display device after the inspection is completed; and attaching driving circuits to the liquid crystal display device having the inspection apparatus removed therefrom.

**[0027]** In accordance with an aspect of the invention, a method of inspecting a display part of a liquid crystal display device, the method includes: providing an inspection appa-

ratus as an integral part of the liquid crystal display device; inspecting the display part of the liquid crystal display device using the inspection apparatus; covering the inspection apparatus with a light cut-off layer after the inspection is completed; and attaching driving circuits to the liquid crystal display device after the inspection is completed.

[0028] In accordance with an aspect of the invention, an inspection apparatus for a liquid crystal display device, the liquid crystal device including a plurality of signal wirings, a plurality of driving switch devices and a plurality of capacitors formed on a substrate and formed in an effective display area of the liquid crystal display device, the apparatus includes: at least one inspection line formed at an exterior of the effective display area of the liquid crystal display device; at least one inspection switch device connected to the at least one inspection line and formed at an exterior of the effective display area; a light source to radiate light onto the at least one inspection switch device, so as to turn on the at least one inspection switch device and to charge an inspection voltage from the at least one inspection line onto one of the capacitors; and a control part to read the charged voltage of the one of the capacitors and thereby determine if there is a defect in the effective display area of the liquid crystal display device.

[0029] In accordance with an aspect of the invention, an apparatus for inspecting a substrate of a liquid crystal display device, the substrate including a plurality of signal wirings, a plurality of drive switches and a plurality of capacitors formed in an effective display area of the substrate, the apparatus includes: a light source to radiate light; at least one inspection line formed at an exterior of the effective display area of the substrate; at least one inspection switch device connected to the at least one inspection line and formed at an exterior of the effective display area of the substrate, wherein the at least one inspection switch device is radiated with the light from the light source so as to be turned on to supply an inspection voltage of the at least one inspection line to a corresponding one of the drive switches, whereby a corresponding one of the capacitors is charged through the signal wirings; and a determining part to determine if there is a defect in the effective display area of the substrate by reading the charged voltage of the corresponding one of the capacitors.

[0030] In accordance with an aspect of the invention, a display part of a liquid crystal display device, includes: a substrate; a display circuit on the substrate for performing a display function of the liquid crystal display device; and an inspection apparatus formed at an exterior of the display circuit and being a removable portion of the liquid crystal display device, wherein after the display circuit is inspected for any defect using the inspection apparatus, the inspection apparatus is removed from the liquid crystal display device.

[0031] In accordance with an aspect of the invention, a display part of a liquid crystal display device, includes: a substrate; a display circuit on the substrate for performing a display function of the liquid crystal display device; an inspection apparatus formed as an integral part of the liquid crystal display device at an exterior of the display circuit; and a light cut-off layer covering the inspection apparatus after the display circuit is inspected using the inspection apparatus; and driving circuits attached to the liquid crystal display device after the display circuit is inspected using the inspection apparatus.

[0032] These and other objects of the present application will become more readily apparent from the detailed description given hereinafter. However, it should be understood that the detailed description and specific examples, while indicating preferred embodiments of the invention, are given by way of illustration only, since various changes and modifications within the spirit and scope of the invention will become apparent to those skilled in the art from this detailed description.

#### BRIEF DESCRIPTION OF THE DRAWINGS

[0033] These and other objects of the invention will be apparent from the following detailed description of the embodiments of the present invention with reference to the accompanying drawings, in which:

[0034] FIG. 1 is a perspective view illustrating a liquid crystal display device of an active matrix type of the related art;

[0035] FIG. 2 is a circuit diagram illustrating an inspection device of the related art for inspecting a liquid crystal display device;

[0036] FIG. 3 is a block diagram illustrating an inspection device of a liquid crystal display device according to an embodiment of the present invention;

[0037] FIG. 4 illustrates a substrate of a liquid crystal display device according to an embodiment of the present invention;

[0038] FIG. 5 is a diagram for explaining a writing process of an inspection voltage with respect to an inspection method of a liquid crystal display device according to an embodiment of the present invention;

[0039] FIG. 6 is a diagram for explaining a reading process of a storage capacitor voltage with respect to an inspection method of a liquid crystal display device according to an embodiment of the present invention;

[0040] FIG. 7 illustrates a state that a data driving circuit and a gate/scan driving circuit are installed on a substrate of a liquid crystal display device after an edge of the substrate is removed along a cutting line 400 shown in FIG. 4 according to an embodiment of the present invention; and

[0041] FIG. 8 illustrates a state that an inspection circuit shown in FIG. 4 is shielded with a light cutting-off layer, and a data driving circuit and a gate driving circuit are installed on a substrate of a liquid crystal display device according to another embodiment of the present invention.

#### DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

[0042] Reference will now be made in detail to the preferred embodiments of the present invention, examples of which are illustrated in the accompanying drawings.

[0043] Hereinafter, as referring to FIGS. 3 to 8, the preferred embodiments of the present invention will be explained in full detail.

[0044] Referring to FIG. 3, an inspection device for a liquid crystal display according to a preferred embodiment of the present invention includes a light source 1 for radiating a light 1a on a substrate 8 to be inspected, a writing and

reading circuit 6, a voltage source 7 for supplying an inspection voltage to the writing and reading circuit 6, a light source driving circuit 2 for driving the light source 1, a display device 4, and a controlling and determining circuit 3 for controlling a user interface device 5. All the components of the inspection device are operatively coupled. The substrate 8 includes a TFT array formed thereon and is part of a liquid crystal display device.

[0045] The light source 1 is driven by a power from the light source driving circuit 2 to generate the light 1a which will then be focused on the substrate 8 to be inspected.

[0046] The writing and reading circuit 6 supplies the inspection voltage from the voltage source 7 (or some other source) to an inspection terminal of the substrate 8 under control of the controlling and determining circuit 3, and reads the voltage generated in the substrate 8 in response to the inspection voltage. The writing and reading circuit 6 supplies the read voltage to the controlling and determining circuit 3.

[0047] The controlling and determining circuit 3 controls the light source driving circuit 2 to turn on or off the light source 1 and controls the writing and reading circuit 6. Further, the controlling and determining circuit 3 compares the read voltage from the writing and reading circuit 6 with a predetermined reference voltage and determines a badness/defectiveness of the substrate 8 being inspected in accordance with the comparison result. Then the controlling and determining circuit 3 generates determination result data and supplies the determination result data to the display device 4 so that the determination result can be displayed to a user or an inspection operator. This allows the user or inspection operator to recognize the defectiveness of the substrate 8 in real time. The user or inspection operator can issue a command or instruction to process the defective substrate via the user interface 5 such as a keyboard, a mouse, etc.

[0048] The controlling and determining circuit 3 can include a ROM (or other memory) having the predetermined reference data voltages stored therein in a lookup table or some other format, so that the reference voltages can be accessed and used to compare with the read voltage. The controlling and determining circuit 3 can include an operation device for performing the detect determination test for the substrate. The operation device may be implemented with one or more computer programs embodied on a computer-readable medium such as ROM, optical disc, etc.

[0049] Further, the inspection device according to the embodiment of the present invention includes a stage for moving the substrate 8 to be inspected and/or a unit for moving the light source 1 such as an actuator.

[0050] FIG. 4 illustrates an example of a TFT array substrate of a liquid crystal device according to the embodiment of the present invention. For instance, the substrate 8 in FIG. 3 can be the substrate having the structure shown in FIG. 4.

[0051] Referring to FIG. 4, the TFT array substrate according to the present invention includes data lines DL1 to DLm and gate lines DGL and GL1 to GLn crossing mutually, TFTs formed at the intersections of the data lines DL1 to DLm and the gate lines DGL and GL1 to GLn, a storage capacitor Cst connected to each of the TFTs, an electrostatic damage protection line 404 crossing with the data lines DL1

to DLm and the gate lines DGL and GL1 to GLn, electrostatic damage protection devices 403a and 403c connected between the electrostatic damage protection line 404 and the data lines DL1 to DLm, and electrostatic damage protection devices 403b and 403d connected between the electrostatic damage protection line 404 and the gate lines DGL and GL1 to GLn. These components are all operatively coupled.

[0052] An inspecting voltage is applied selectively or simultaneously to the data lines DL1 to DLm during the inspecting process, whereas the video data is supplied to the data lines DL1 to DLm upon a normal driving.

[0053] The gate lines DGL and GL1 to GLn include an uppermost dummy gate line DGL not connected to the TFTs and the gate lines GL1 to GLn connected to the TFTs. The gate lines DGL and GL1 to GLn supply the inspection voltage to the TFTs during the inspection process to select a line having the inspection voltage supplied thereto, and supply the driving scan voltage to the TFTs to select the line having the video data voltage supplied thereto upon a normal driving.

[0054] The gate electrodes of the TFTs are connected to the gate lines GL1 to GLn and the source electrodes of the TFTs are connected to the data lines DL1 to DLm. The drain electrodes of the TFTs are connected to the storage capacitors Cst. Each TFT is turned on when the scan voltage higher than the threshold voltage of the corresponding TFT is supplied to the corresponding one of the gate lines GL1 to GLn, which in turn supplies the voltage on the corresponding one of the data lines DL1 to DLm to the corresponding storage capacitor Cst.

[0055] For each TFT, the storage capacitor Cst is formed between the drain electrode of the TFT and the prestage gate line or is formed between the drain electrode of the TFT and a separate common electrode line (not shown). The storage capacitor Cst charges the inspection voltage during the inspection process and then discharges the charged voltage. The controlling and determining circuit 3 shown in FIG. 3 compares the voltage discharged from the storage capacitor Cst with a predetermined reference voltage in the inspection process, and thus determines a point of defect such as the short of the TFT and the storage capacitor, or the short and the open circuit problem of the corresponding gate line and the corresponding data line based on the comparison results.

[0056] The device for protecting an electrostatic discharge damage (hereinafter referred to as "ESD protection device") bypasses the static electricity caused during the fabricating process or the normal driving to the electrostatic damage protection line (hereinafter referred to as "ESD protection line") and thus protects the TFT array of an effective display from the static electricity. A ground voltage GND or a common voltage Vcom is supplied to the ESD protection line 404.

[0057] Further, the TFT array substrate according to the present invention includes first to third inspection lines 401, 402 and 405 formed at an outer edge portion of the TFT array of the effective display, first and third inspection TFTs T1 and T3 having their gate terminals connected to the first inspection line 401, second TFTs T2 connected between the second inspection line 402 and the gate lines GL1 to GLn of the TFT array, capacitors C1 each connected between the first and the second TFTs T1 and T2, fourth TFTs T4

connected between the third inspection line **405** and the data lines DL1 to DLm of the TFT array, and capacitors C2 each connected between the third and fourth TFTs T3 and T4.

[0058] The first inspection line **401** receives from, e.g., the voltage source 7 a gate-off voltage (Vg-off) lower than the threshold voltage of the first and the third TFTs T1 and T3 and supplies it to the TFTs T1 and T3 in the inspection process, while upon the normal driving, it is provided with no voltage.

[0059] The second inspection line **402** receives from, e.g., the voltage source 7 a gate-on voltage (Vg-on) higher than the threshold voltage of the second and the fourth TFTs T2 and T4 and supplies it to the TFTs T1, T2, and T3 in the inspection process, while upon the normal driving, it is provided with no voltage.

[0060] The third inspection line **405** receives from, e.g., the voltage source 7 the inspection voltage Vds and supplies it to the sources of the fourth TFTs T4 in the inspection process. It also receives the read voltage Vcst from the data lines DL1 to DLm. The third inspection line **405** is provided with no voltage upon the normal driving.

[0061] For each first TFT T1, the gate electrode of the first TFT T1 is connected to the first inspection line **401** and the source electrode of the first TFT T1 is connected to the second inspection line **402**. The drain electrode of the first TFT T1 is connected to the capacitor C1. The first TFT T1 is turned on by a photo current generated due to the exposure to the light **1a** from the light source 1 in the inspection process and thereby supplies a gate-on voltage (Vg-on) on the second inspection line **402** to the capacitor C1.

[0062] For each second TFT T2, the gate electrode of the second TFT T2 is connected to the capacitor C1 and the source electrode of the second TFT T2 is connected to the second inspection line **402**. The drain electrode of the second TFT T2 is connected to the corresponding one of the gate lines GL1 to GLn. The second TFT T2 is turned on in response to the voltage of the capacitor C1 in the inspection process, and the turned-on T2 supplies the gate-on voltage (Vg-on) on the second inspection line **402** to the corresponding one of gate lines GL1 to GLn and thus to the TFTs of the array connected to that gate line.

[0063] For each third TFT T3, the gate electrode of the third TFT T3 is connected to the first inspection line **401** and the source electrode of the third TFT T3 is connected to the second inspection line **402**. The drain electrode of the third TFT T3 is connected to the capacitor C2. The third TFT T3 is turned on by the photo current generated due to the exposure to the light from the light source 1 in the inspection process, which supplies a gate-on voltage (Vg-on) on the second inspection line **402** to the capacitor C2.

[0064] For each fourth TFT T4, the gate electrode of the fourth TFT T4 is connected to the capacitor C2 and the source electrode of the fourth TFT T4 is connected to the third inspection line **405**. The drain electrode of the fourth TFT T4 is connected to the corresponding one of the data lines DL1 to DLm. The fourth TFT T4 is turned on in response to the voltage of the capacitor C2 in the inspection process, which in turn supplies the inspection voltage Vds on the third inspection line **403** to the corresponding one of the data lines DL1 to DLm. Also, it supplies the read voltage

Vcst from the corresponding one of the data lines DL1 to DLm to the third inspection line **405** for reading by the writing and reading circuit 6.

[0065] When the first and third TFTs T1 and T3 are turned on, the capacitors C1 and C2 charge the voltage and constantly supply the charged voltage to the gate terminal of the second and fourth TFTs T2 and T4, to thereby stably maintain the gate voltage of the second and fourth TFTs T2 and T4.

[0066] The inspection process on the TFT array substrate according to an embodiment of the present invention includes a sequence of loading the TFT array substrate shown in FIG. 4 or other substrate to the inspection device, writing the inspection voltage Vds to the TFT array and reading the return signal from the TFT array in response to the inspection voltage. Here, the loading step may be optional if the inspection device is part of the TFT array substrate (which will be discussed later in more detail). More specifically, the TFT array substrate shown in FIG. 4 is loaded in the inspection device and then the writing process of the inspection voltage as shown in FIG. 5 is performed.

[0067] Referring to FIG. 5, in the writing process of the inspection voltage, the inspection voltage Vds (e.g., from the voltage source 7) via the reading and writing circuit 6 shown in FIG. 3 is supplied to the third inspection line **405**, and the light is radiated by the light source 1 onto a semiconductor layer of the first TFT T1 and in turn onto a semiconductor layer of the third TFT T3. In this writing process, the first TFT T1 is turned on by the photo current generated in its semiconductor layer and the second TFT T2 is turned on by the voltage of the capacitor C1. The second TFT T2, as turned on, supplies the gate-on voltage (Vg-on) on the second inspection line **402** to the corresponding one of the gate lines GL1 to GLn. Similarly, the third TFT T3 is turned on by the photo current generated in its semiconductor layer and the fourth TFT T4 is turned on by the voltage of the capacitor C2, so as to supply the inspection voltage Vds on the third inspection line **405** to the corresponding one of the data lines DL1 to DLm. Then the TFTs of the effective display area connected to the corresponding gate line are turned on to pass the inspection voltage Vds through the TFT(s) and to charge the inspection voltage Vds to the corresponding storage capacitor Cst. That is, the storage capacitor Cst charges electric charges supplied through a current path i via the third inspection line **405**, the corresponding one of the data lines DL1 to DLm and the TFT in the TFT array in the writing process of the inspection voltage.

[0068] In one embodiment, the light source 1 sequentially radiates the light **1a** to the first and third TFTs T1 and T3 by moving with a constant speed or moving of the stage for supporting the TFT array substrate, or simultaneously radiates the light **1a** to all the first and third TFTs T1 and T3. During the sequential radiating, all the first TFTs T1 can be sequentially radiated and, at the same time or before or after, all the third TFTs T3 can be sequentially radiated. In the alternative, the first and second TFTs T1 and T3 can be selectively radiated if a particular area (e.g., a particular TFT or Cst) on the TFT array needs to be inspected. Other variations are possible.

[0069] After the writing process of the inspection voltage, the reading process of the read voltage is performed, as

shown in **FIG. 6**. Referring to **FIG. 6**, in the reading process of the read voltage, no voltage is applied from an external to the third inspection line **405** and the light source **1** radiates the light **1a** to the semiconductor layer of the first TFT **T1** and to the semiconductor layer of the third TFT **T3**. In the reading process, the first TFT **T1** is turned on by the photo current generated in its semiconductor layer and the connected second TFT **T2** is turned on by the voltage of the capacitor **C1** to supply the gate-on voltage ( $V_{g-on}$ ) on the second inspection line **402** to the corresponding one of the gate lines **DGL** and **GL1** to **GLn**. Similarly, the third TFT **T3** is turned on by the photo current generated in its semiconductor layer and the connected fourth TFT **T4** is turned on by the voltage of the capacitor **C2** to form the current path between the corresponding one of the data lines **DL1** to **DLm** and the third inspection line **405**. Consequently, the TFTs of the effective display connected to the corresponding gate line are turned on to form the current path between the storage capacitor **Cst** and the corresponding data lines. Then the voltage **Vest** of the storage capacitor **Cst** (charged with the inspection voltage) is discharged along the current path including the corresponding TFT, the corresponding data line and the third inspection line **405**, which will then be supplied to the writing and reading circuit **6** shown in **FIG. 3**.

**[0070]** In one embodiment, the order or manner in which the first and third TFT(s) **T1** and **T3** are radiated during the reading process of the inspection procedure can be the same as or reverse of the order or manner in which the first and third TFT(s) **T1** and **T3** are radiated in the writing process of the inspection voltage. In another embodiment, the first and third TFT(s) **T1** and **T3** can be radiated selectively according to an order in which particular areas of the TFT array are desired to be inspected.

**[0071]** The writing and reading circuit **6** amplifies the read voltage **Vest** supplied from the TFT array, removes a noise therein and supplies the processed read voltage **Vest** to the controlling and determining circuit **3**. The controlling and determining circuit **3** compares the read voltage **Vest** with a predetermined reference data voltage to determine the presence of a defect in the storage capacitor of the TFT array and in the TFT and the presence of short and/or open circuit defectiveness in the data lines **DL1** to **DLm** and gate lines **GL1** to **GLn** in accordance with the comparison results. The precise location of the defect can be quickly identified by examining which one of the first TFTs **T1** and which one of the third TFTs **T3** have been radiated to read the charge inspection voltage. This is because each of the first TFTs **T1** is assigned to one of the gate lines, and each of the third TFTs **T3** is assigned to one of the data lines.

**[0072]** The controlling and determining circuit **3** supplies the data of the read voltage **Vest** and/or the comparison result to the display device **4** or other indication device to allow an inspection operator or user recognize the defect in real time.

**[0073]** In one embodiment, the inspection device is a removable part of the TFT array substrate. In this case, the edge of the TFT array substrate is cut off along a cutting line **400** of **FIG. 4** upon the scribing process. Accordingly, the first to the fourth TFTs **T1** to **T4**, the capacitors **C1** and **C2** and the first to the third inspection lines **401**, **402** and **405** are removed from the TFT array substrate after the inspection is

completed. Then, after forming the liquid crystals **Clc** by the alignment film forming/rubbing process and the substrate assembling/liquid crystal injecting process, integrated circuits of a data driving circuit **702** and a scan driving circuit **701** are mounted on the TFT array substrate as shown in **FIG. 7**.

**[0074]** The data driving circuit **702** supplies video data to the data lines **DL1** to **DLm** under control of the timing controller (not shown). The scan driving circuit **701** sequentially supplies a scan pulse to the gate lines **GL1** to **GLn** in response to the gate start pulse from the timing controller to select the lines to which the video data voltage is supplied. This process is known.

**[0075]** In other variations, upon the scribing process, the first to the fourth TFTs **T1** to **T4**, the capacitors **C1** and **C2** and the first and the third inspection lines **401**, **402** and **405** may be remained on the TFT array substrate without being removed from the TFT array substrate. In this case, as shown in **FIG. 8**, it is preferred to form a light cut-off layer **803** covering or overlapping the inspection device including the TFTs **T1** to **T4** and the inspection lines, so that the TFTs **T1** to **T4** on the edge of the TFT array substrate do not cause a false operation. Then, after forming the liquid crystal cells **Clc** by the alignment film forming/rubbing process and substrate assembling/liquid crystal injecting process, the integrated circuits of a data driving circuit **802** and a scan driving circuit **801** are mounted on the TFT array substrate.

**[0076]** The processing steps and computer programs of the present invention are implementable using existing computer programming language. Such computer program(s) may be stored in memories such as RAM, ROM, PROM, etc. associated with computers. Alternatively, such computer program(s) may be stored in a different storage medium such as a magnetic disc, optical disc, magnet-optical disc, etc. Such computer program(s) may also take the form of a signal propagating across the Internet, extranet, intranet or other network and arriving at the destination device for storage and implementation. The computer programs are readable using a known computer or computer-based device.

**[0077]** As described above, the method and apparatus for inspecting the liquid crystal display device provide the inspection lines and the TFTs at an edge area of the TFT array substrate, radiate the light to the TFTs in order to charge the inspection voltage to the storage capacitor of the TFT array substrate, and read the voltage of the storage capacitor of the TFT array substrate to find the defect in the TFT and the storage capacitor formed on the TFT array substrate and the short and the open circuit problems of the signal wirings. As a result, the method and apparatus for inspecting the liquid crystal display device according to the present invention do not need a separate jig and can detect the defect location precisely and rapidly.

**[0078]** Although the present invention has been explained by the embodiments shown in the drawings described above, it should be understood to the ordinary skilled person in the art that the invention is not limited to the embodiments, but rather that various changes or modifications thereof are possible without departing from the spirit of the invention. Accordingly, the scope of the invention shall be determined only by the appended claims and their equivalents.

What is claimed is:

1. A method of inspecting a liquid crystal display device using an inspection apparatus, the inspection apparatus including a light source, at least one inspection line and at least one inspection switch device connected to the inspection line, the method comprising:

providing a substrate, wherein the substrate includes a plurality of signal wirings, a plurality of drive switches, and a plurality of capacitors formed in an effective display area of the substrate;

radiating a light generated from the light source of the inspection apparatus onto the at least one inspection switch device and thereby supplying an inspection voltage from the at least one inspection line to a corresponding one of the drive switches through the signal wirings, so as to charge a corresponding one of the capacitors; and

determining if there is a defect in the effective display area of the substrate by reading the charged voltage of the corresponding one of the capacitors.

2. The method according to claim 1, wherein the determining step includes:

comparing the charged voltage of the corresponding one of the capacitors with a predetermined reference voltage.

3. The method according to claim 1, wherein the signal wirings include a plurality of gate lines, the at least one inspection switch device includes first and second inspection switch devices, and the at least one inspection line includes first and second inspection lines, and

wherein the radiating step includes:

radiating a light from the light source onto the first inspection switch device to turn on the first inspection switch device; and

turning on the second inspection switch device under control of the first inspection switch device and thereby supplying a first inspecting voltage from the first inspection line to a corresponding one of the gate lines, so as to turn on the corresponding one of the driving switches.

4. The method according to claim 3, wherein the signal wirings further include a plurality of data lines, and the at least one inspection switch device further includes third and fourth inspection switch devices, and

wherein the radiating step further includes:

radiating a light onto the third inspection switch device to turn on the third inspection switch device; and

turning on the fourth inspection switch device under control of the third inspection switch device and thereby supplying a second inspection voltage from the second inspection line to a corresponding one of the data lines, so as to charge the corresponding one of the capacitors.

5. The method according to 4, wherein the determining step includes:

radiating a light onto the first and third inspection switch devices; and

reading the charged voltage of the corresponding one of the capacitors, to thereby determine if there is a defect in at least one of the signal wirings, the driving switch devices and the capacitors.

6. The method according to claim 1, wherein the inspection apparatus is formed on the substrate as part of the substrate.

7. The method according to claim 1, further comprising: informing a user of the determination result in real time.

8. A method of inspecting a substrate device, the substrate device including signal wirings, drive switches and capacitors formed in a main area of the substrate device, and an inspection line and an inspection switch formed at an exterior of the main area, the drive switches being coupled to the capacitors, the inspection switch being coupled to the inspection line, the method comprising:

supplying an inspection voltage to the inspection line of the substrate device;

charging one of the capacitors with the inspection voltage through the signal wirings; and

determining if there is a defect in the substrate device by reading the charged voltage of the capacitor.

9. The method according to claim 8, wherein the determining step includes:

comparing the charged voltage of the capacitor with a predetermined reference voltage; and

determining whether or not there is a defect in one of the signal wirings, a corresponding one of the drive switches, or the charged capacitor based on the comparison result.

10. The method according to claim 8, wherein the charging step includes:

turning on a corresponding one of the drive switches; and radiating a light onto the inspection switch to turn on the inspection switch, so as to charge the one of the capacitors.

11. The method according to claim 8, further comprising:

severing, from the substrate device, the inspection line and the inspection switch formed at the exterior of the main area of the substrate device after an inspection of the main area is completed.

12. The method according to claim 8, further comprising:

covering, with a light cut-off layer, the inspection line and the inspection switch formed at the exterior of the main area of the substrate device after an inspection of the main area is completed.

13. A method of inspecting a display part of a liquid crystal display device, the method comprising:

providing an inspection apparatus as a removable portion of the liquid crystal display device;

inspecting the display part of the liquid crystal display device using the inspection apparatus;

removing the inspection apparatus from the liquid crystal display device after the inspection is completed; and

attaching driving circuits to the liquid crystal display device having the inspection apparatus removed therefrom.

**14.** The method according to claim 13, wherein in the attaching step, the driving circuits are attached to areas of the liquid display device where the inspection apparatus was previously located.

**15.** A method of inspecting a display part of a liquid crystal display device, the method comprising:

providing an inspection apparatus as an integral part of the liquid crystal display device;

inspecting the display part of the liquid crystal display device using the inspection apparatus;

covering the inspection apparatus with a light cut-off layer after the inspection is completed; and

attaching driving circuits to the liquid crystal display device after the inspection is completed.

**16.** The method according to claim 15, wherein in the attaching step, the driving circuits are attached to certain sides of the liquid crystal display device other than those sides of the liquid crystal display device where the covered inspection apparatus is located.

**17.** An inspection apparatus for a liquid crystal display device, the liquid crystal device including a plurality of signal wirings, a plurality of driving switch devices and a plurality of capacitors formed on a substrate and formed in an effective display area of the liquid crystal display device, the apparatus comprising:

at least one inspection line formed at an exterior of the effective display area of the liquid crystal display device;

at least one inspection switch device connected to the at least one inspection line and formed at an exterior of the effective display area;

a light source to radiate light onto the at least one inspection switch device, so as to turn on the at least one inspection switch device and to charge an inspection voltage from the at least one inspection line onto one of the capacitors; and

a control part to read the charged voltage of the one of the capacitors and thereby determine if there is a defect in the effective display area of the liquid crystal display device.

**18.** The apparatus according to claim 17, wherein the at least one inspection switch device includes:

a first transistor to be turned on in response to the light from the light source; and

a second transistor to be turned on in response to an output voltage of the first transistor.

**19.** The apparatus according to claim 18, wherein the at least one inspection line includes:

a first inspection line to which a gate-off voltage lower than a threshold voltage of the first transistor is supplied and a gate terminal of the first transistor is connected; and

a second inspection line to which a gate-on voltage higher than a threshold voltage of the second transistor is supplied and a source terminal of each of the first and second transistors is connected.

**20.** The apparatus according to claim 19, wherein the signal wirings include:

a gate line connected to the second transistor; and

a plurality of data lines crossing with the gate line.

**21.** The apparatus according to claim 20, wherein a drain terminal of the first transistor is connected to a gate terminal of the second transistor and a drain terminal of the second transistor is connected to the gate line.

**22.** The apparatus according to claim 18, further comprising:

a capacitor connected between a drain terminal of the first transistor and a gate terminal of the second transistor to stabilize a gate voltage of the second transistor.

**23.** The apparatus according to claim 17, wherein the at least one inspection switch device includes:

a third transistor to be turned on in response to the light from the light source; and

a fourth transistor to be turned on in response to an output voltage of the third transistor.

**24.** The apparatus according to claim 23, wherein the at least one inspection line includes:

a first inspection line to which a gate-off voltage lower than a threshold voltage of the third transistor is supplied and a gate terminal of the third transistor is connected;

a second inspection line to which a gate-on voltage higher than a threshold voltage of the fourth transistor is supplied and a source terminal of the third transistor is connected; and

a third inspection line through which the charged voltage of the one of the capacitors is transmitted after the inspection voltage is applied and to which a source terminal of the fourth transistor is connected.

**25.** The apparatus according to claim 24, wherein the signal wirings include:

a data line connected to the forth transistor; and

a plurality of gate lines crossing the data line.

**26.** The apparatus according to claim 25, wherein a drain terminal of the third transistor is connected to a gate terminal of the fourth transistor and a drain terminal of the fourth transistor is connected to the data line.

**27.** The apparatus according to claim 23, further comprising:

a capacitor connected between a drain terminal of the third transistor and a gate terminal of the fourth transistor to stabilize a gate voltage of the fourth transistor.

**28.** The apparatus according to claim 17, further comprising:

a light cutting-off layer to shield the at least one inspection switch device and the at least one inspection line from light.

**29.** An apparatus for inspecting a substrate of a liquid crystal display device, the substrate including a plurality of signal wirings, a plurality of drive switches and a plurality of capacitors formed in an effective display area of the substrate, the apparatus comprising:

a light source to radiate light;

at least one inspection line formed at an exterior of the effective display area of the substrate;

at least one inspection switch device connected to the at least one inspection line and formed at an exterior of the effective display area of the substrate, wherein the at least one inspection switch device is radiated with the light from the light source so as to be turned on to supply an inspection voltage of the at least one inspection line to a corresponding one of the drive switches, whereby a corresponding one of the capacitors is charged through the signal wirings; and

a determining part to determine if there is a defect in the effective display area of the substrate by reading the charged voltage of the corresponding one of the capacitors.

**30.** The apparatus according to claim 29, wherein the determining part compares the charged voltage of the corresponding one of the capacitors with a predetermined reference voltage to make the determination.

**31.** The apparatus according to claim 29, wherein the wiring signals include a plurality of gate lines, the at least one inspection line includes first and second inspection lines, and the at least one inspection switch device includes first and second inspection switch devices.

**32.** The apparatus according to claim 31, wherein the first inspection switch device is turned on in response to the light from the light source, the second inspection switch device is turned on under control of the first inspection switch device to supply a first inspecting voltage from the first inspection line to a corresponding one of the gate lines, which turns on the corresponding one of the drive switches.

**33.** The apparatus according to claim 32, wherein the wiring signals further include a plurality of data lines and the at least one inspection switch device further includes third and fourth inspection switch devices, and

wherein a light from the light source is radiated onto the third inspection switch device to control the third inspection switch device, the fourth inspection switch device is turned on under control of the third inspection switch device to supply a second inspection voltage from the second inspection line to a corresponding one of the data lines so as to charge the corresponding one of the capacitors.

**34.** The apparatus according to 33, wherein a light from the light source is radiated onto the first and third inspection switch devices, and the determining part determines if there is a defect in at least one of the signal wirings, the drive switches and the capacitors based on the charged voltage of the one of the capacitors.

**35.** The apparatus according to claim 29, wherein the apparatus is part of the substrate.

**36.** The apparatus according to claim 29, further comprising:

means for informing a user of the determination result in real time.

**37.** A display part of a liquid crystal display device, comprising:

a substrate;

a display circuit on the substrate for performing a display function of the liquid crystal display device; and

an inspection apparatus formed at an exterior of the display circuit and being a removable portion of the liquid crystal display device,

wherein after the display circuit is inspected for any defect using the inspection apparatus, the inspection apparatus is removed from the liquid crystal display device.

**38.** The display part according to claim 37, further comprising:

driving circuits attached to the exterior of the display circuit once the inspection apparatus is removed.

**39.** A display part of a liquid crystal display device, comprising:

a substrate;

a display circuit on the substrate for performing a display function of the liquid crystal display device;

an inspection apparatus formed as an integral part of the liquid crystal display device at an exterior of the display circuit; and

a light cut-off layer covering the inspection apparatus after the display circuit is inspected using the inspection apparatus; and

driving circuits attached to the liquid crystal display device after the display circuit is inspected using the inspection apparatus.

**40.** The display part according to claim 39, wherein the driving circuits are attached to certain sides of the liquid crystal display device other than those sides of the liquid crystal display device where the covered inspection apparatus is located.

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## 摘要(译)

提供了一种用于测试液晶显示装置的方法和装置，以在不需要夹具的情况下精确且快速地检测缺陷位置。该方法包括提供检查基板，其中基板包括信号布线，驱动开关和形成在基板的有效显示区域中的电容器;将光照射到检查开关装置上，从而通过信号配线从检查线向一个驱动开关提供检查电压，以便对一个电容器充电;通过读取电容器的充电电压确定基板的有效显示区域是否存在缺陷。

